IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MAIL STOP: AMENDMENT

Naoaki OGURE et al.

Confirmation No. 7255

Serial No. 09/866,843

Docket No. 2001 0686A

Filed May 30, 2001

Group Art Unit 1763

COATING, MODIFICATION AND ETCHING OF SUBSTRATE SURFACE WITH PARTICLE BEAM IRRADIATION OF THE SAME Examiner G.A. GOUDREAU

**AMENDMENT** 

OCCUMISSIONER IS AUTHORIZED OCCUMINATIONER IS AUTHORIZE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed April 7, 2004, the time for responding thereto being extended for one month in accordance with a Petition for Extension submitted herewith, please amend the above-identified application as follows: